Application/Control No.	Applicant(s)/Patent under Reexamination	
10/726,802	KOBAYASHI, OSAMU	
Examiner	Art Unit	
Chun-Kuan (Mike) Lee	2181	

	SEARCHED					
Class	Subclass	Date	Examiner			
710	62 .	1/8/2008	CKL			
		····				

INTERFERENCE SEARCHED						
Class	Subclass	· Date	Examiner			
710	62	1/8/2008	CKL			
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
Updated EAST search:US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT Updated Inventor search utilizing eDan and EAST	1/8/2008	CKL	
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